



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Yoshi NISHIBAYASHI, et al.

Serial No.: 09/942,101

Group Art Unit: 1765

Filed: August 30, 2001

Examiner:

For:

METHOD OF MANUFACTURING ELECTRON-EMITTING ELEMENT AND

ELELCTRONIC DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

The relevance of each non-English language reference, if any, is discussed in the present specification.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

Arthur Jl Steiner

Registration No. 26,106

600 13th Street, N.W. Washington, DC 20005-3096 (202) 756-8000 AJS:prp

Date: November 27, 2001 Facsimile: (202) 756-8087